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| Notice of References Cited | Application/Control No. 10/712,446 | Applicant(s)/Patent Under Reexamination THOMAS ET AL. | |
| | Examiner Patricia A. George | Art Unit 1765 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|--------------------|----------------|
| | A | US-6,821,897 | 11-2004 | Schroeder et al. | 438/692 |
| | B | US-6,620,215 | 09-2003 | Li et al. | 51/298 |
| | C | US-5,861,005 | 01-1999 | Kontos, Stavros B. | 606/219 |
| | D | US-6,063,306 | 05-2000 | Kaufman et al. | 252/79.4 |
| | E | US-6,699,299 | 03-2004 | Sachan et al. | 51/298 |
| | F | US-6,293,848 | 09-2001 | Fang et al. | 451/36 |
| | G | US-6,582,633 | 06-2003 | Elfving et al. | 264/53 |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | Chapter 2: Characterization and Optimization of the CMP Process; Mechanics, mechanisms, and modeling of the CMP proces; Lai, jiun-Yu; MIT Thesis (Ph.D.) Dept. of Mechanical Engineering, 2001, found at the Barker Library in microforms, stacks and web-site. |
| | V | |
| | W | |
| | X | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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